| | MISS 3.13.00 | | 04-25-20 | JUU | |
|--|---|--|--|-------------------------------|-------------------------------------|
| Form-PTO-1595 TRANSMITTAL C 1-31-92 | | | | Atty. Docket: 35.C14077 | |
| | To the Commissioner of I | Patents and Tradema | 1012220 | 773 | uments or copy thereof. |
| 1. | Name of conveying party(ies): (1) Takao YONEHARA (2) Kunio WATANABE (3) Testsuya SHIMADA (4) Kazuaki Ol-Ml (5) Kiyofumi SAKAGUCHI | MAR 1 3 2000 MAR 1 3 2000 | Name: CAN | ON KABUSHIKI | ving party(ies): |
| | | g party(ies) attached? X No | Domestic Ac | ddress: | |
| 3. | Nature of conveyance: X Assignment Security Agreement Other | [] Change of Name | | | State ZIP |
| | Execution Date: (1) January 15, (3, 4, 5) Janua | | 000 | | |
| 4. | A. Patent Application Number Filing Date: December 3, 1 | ogether with a new appli : 09/453,539 | B. Title METHOD C WAFER ME SAME | of Invention: OF MANUFACTU | uring SEMICONDUCTOR |
| 5. | Name and address of party to w | • | 6. Number | of applications an | nd patents involved: |
| | Name: <u>Fitzpatrick</u> | | | | One |
| | 30 Rockefell | er Plaza | | e (37 CFR 3.41): | \$40.00 |
| | New York, I | New York 10112-3801 | | orized to be charg | ged to deposit account |
| | Telephone No.:(212) 218-21 | 00 | 8. Deposit a | | for deficiency or excess) 6-1205 |
| | 'acsimile No.:(212) 218-22 | 200 | (Attach d | | is page if paying by deposit |
| | <i>f</i> | DO NO | Γ USE THIS SPACE | | |
|)19 <u>F</u> C | To the best of my knowledge and true copy of the or ginal documents | d betief, the foregoing in | | the attached is th | e original document or is a |
| Ste | ven E. Warner - Reg. No. 33,326 | teven | hamas | March | 13, 2000 |
| | Name of Person Signing | Total | Signature | | Date |
| L | | lotal nu | noer or pages including | ig cover sheet, att | achments, and documents: 2 |

SEW\cmv

DO_MAIN 17286 v 1

PATENT REEL: 010715 FRAME: 0707

JOINT

(AFTER APPLICATION FILLED)

ASSIGNMENT OF PATENT RIGHTS FOR THE UNITED STATES

FOR VALUE RECEIVED, WE, TAKAO YONEHARA, KUNIO WATANABE, TETSUYA SHIMADA, KAZUAKI OHMI and KIYOFUMI SAKAGUCHI

citizens of Japan
residing respectively at 2235-2, Nurumizu, Atsugi-shi, Kanagawa-ken,
Japan; 14-4, Minami Ikuta 2-chome, Tama-ku, Kawasaki-shi,
Kanagawa-ken, Japan; 26-20-503, Sagamigaoka 6-chome, Zama-shi,
Kanagawa-ken, Japan; 581-4, Niiharu-cho, Midori-ku,
Yokonama-shi, Kanagawa-ken, Japan; and 19-2-504, Eda Higashi
2-chome, Tsuzuki-ku, Yokohama-shi, Kanagawa-ken, Japan
hereby sell, ass gn. transfer and convey unto CANON KABUSHIKI KAISHA
a comporation of Japan

having a place of business at 30-2, Shimomaruko 3-chome, Ohta-ku, Tokyo, Japan its successors, assigns and legal representatives (hereinafter called the "Assignee"), the entire right, title and interest, for the United States, in and to certain inventions relating to

METHOD OF MANUFACTURING SEMICONDUCTOR WAFER METHOD OF USING AND UTILIZING THE SAME

and described in an application for Letters Patent of the United States filed by us on December 3, 1999 and which has been accorded Application No. 09/453,539 and in and to said application, and all divisions, renewals and continuations thereof, and all Letters Patent of the United States which may be granted, thereon, and all reissues and extensions thereof; and we hereby authorize and request the Commissioner for Patents and Trademarks of the United States to issue all Letters Patent upon said inventions to the

Assignee co to such nominees as it may designate.

AND we authorize and empower the said Assignee or nominees to invoke and claim for any application for

patent or other form of protection for said inventions, the benefit of the right of priority provided by the International Convention for the Protection of Industrial Property, as amended, or by any convention which may henceforth be substituted for it, and to invoke and claim such right of priority without further written or oral authorization from us.

AND we hereby consent that a copy of this assignment shall be deemed a full legal and formal equivalent of any assignment consent to file or like document which may be required in the United States for any purpose and more particularly in proof of the right of said Assignee or nominees to claim the aforesaid benefit of the right of priority provided by the International Convention for the Protection of Industrial Property, as amended, or by any convention which may henceforth be substituted for it.

PND we hereby covenant that we have the full right to convey the entire right, title and interest herein assigned and that we have not executed and will not execute any agreement in conflict herewith.

ENE we hereby covenant and agree that we will communicate to said Assignee or nominees all facts known to us pertaining to said inventions, and testify in all legal proceedings, sign all lawful papers, execute all divisional, continuing and reissue applications, make all rightful oaths and declarations and in general perform all lawful acts necessary or proper to aid said Assignee or nominees in obtaining, maintaining and enforcing all lawful patent protection for said in zentions in the United States.

| By Jako Jownson WAKAO YONEHARA | Date: January 15, 2000 |
|----------------------------------|------------------------|
| WARAOYYONEHARA By CUNIO WATANABE | Date: Jan, 20, 2000 |
| By E'SUYA SHIMADA | Date: Juneary 13, 200 |
| By RAZUAKI OHMI | Date: January 13, 2000 |
| By LINGTONI SAKAGUCHI | Date: Juniary 13, 2000 |

PATENT REEL: 010715 FRAME: 0708

RECORDED: 03/13/2000